

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re application of

: **Confirmation No. 4423**

Tomohiro OKUMURA et al.

: Docket No. 2001-1089A

Serial No. 09/918,823

: Group Art Unit 2821

Filed August 1, 2001

: Examiner T. Phan

PLASMA PROCESSING METHOD
AND APPARATUS THEREOF

:

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

Petition hereby is made for a three month extension of time to respond to the communication of
May 21, 2003.

The fee of \$950.00 is

(X) submitted herewith.

() to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is
enclosed.

() Small entity status of this application is established by a Small Entity Status Assertion
which

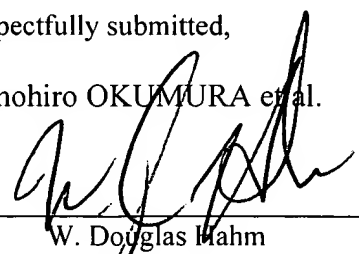
() is enclosed.

() has been previously submitted.

Respectfully submitted,

Tomohiro OKUMURA et al.

By


W. Douglas Mahm
Registration No. 44,142
Attorney for Applicants

11/26/2003 ZJUHA1 00000013 09918823

01 FC:1253

950.00 OP

WDH/gtg
Washington, D.C. 20006-1021
Telephone (202) 721-8200
Facsimile (202) 721-8250
November 21, 2003

TECHNOLOGY CENTER 2809

DEC - 3 2003

RECEIVED